Docket No.

240576US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Yuuichiro MURAHAMA

SERIAL NO: New Application

GAU:

FILED:

Herewith

EXAMINER:

FOR:

SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME, NONVOLATILE SEMICONDUCTOR MEMORY AND METHOD OF FABRICATING THE SAME, AND ELECTRONIC

APPARATUS INCLUDING NONVOLATILE SEMICONDUCTOR MEMORY

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith. or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

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Form PTO 1449 U.S. DEPARTMENT OF C (Modified) PATENT AND TRADEMA			IT OF COMMERCE ADEMARK OFFICE	ATTY DOCKET NO.		SERIAL NO.		
				240576US2		New Application		
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Yuuichiro MURAHAMA				
								FILING DATE
				Herewith				
								U.S. PATENT DOCUMENTS
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
	AA	6,396,086 B1	05/28/02	Yuji TAKEUCHI, et al.				
	AB							
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Examiner						Additional References sheet(s) attached		
*Examiner: Initial if reference is considered, whether or not conformance and not considered.				citation is in conformance with \$400		Date Considered		
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